

## Electronic Acknowledgement Receipt

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<b>International Application Number:</b>	
<b>Confirmation Number:</b>	3715
<b>Title of Invention:</b>	System For Continuous Growing of Monocrystalline Silicon
<b>First Named Inventor/Applicant Name:</b>	David L Bender
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Foreign Reference	Solx4USIDS8b.pdf	162335	no	1
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Warnings:					
Information:					
2	Foreign Reference	1JournCrysGwthCWang.pdf	850390	no	6
			17e06ef21f72f16cf66205869469054ae2fffa 28		
Warnings:					
Information:					
3	Foreign Reference	2JournCrysGwthHopkins1977. pdf	641757	no	6
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5	Foreign Reference	4NRELTHWanetal.pdf	567937	no	7
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Information:					
6	Foreign Reference	5NRELTihuWangShallow.pdf	552596	no	5
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**If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.**

**National Stage of an International Application under 35 U.S.C. 371**

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**New International Application Filed with the USPTO as a Receiving Office**

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